

Interview Summary	Application No.	Applicant(s)	
	10/672,896	LE ET AL.	
	Examiner	Art Unit	
	Tai Van Nguyen	3729	

All participants (applicant, applicant's representative, PTO personnel):

(1) Dominic M. Kotab, Applicants. (3)_____.

(2) Tai Van Nguyen, Examiner.. (4)_____.

Date of Interview: 08 June 2006.

Type: a)☒ Telephonic b)☐ Video Conference
c)☐ Personal [copy given to: 1)☐ applicant 2)☐ applicant's representative]

Exhibit shown or demonstration conducted: d)☐ Yes e)☐ No.

If Yes, brief description: _____.

Claim(s) discussed: 32-34.

Identification of prior art discussed: _____.

Agreement with respect to the claims f)☐ was reached. g)☒ was not reached. h)☐ N/A.

Substance of Interview including description of the general nature of what was agreed to if an agreement was reached, or any other comments: Applicants have agreed to the examiner's amendment attached herein.

(A fuller description, if necessary, and a copy of the amendments which the examiner agreed would render the claims allowable, if available, must be attached. Also, where no copy of the amendments that would render the claims allowable is available, a summary thereof must be attached.)

THE FORMAL WRITTEN REPLY TO THE LAST OFFICE ACTION MUST INCLUDE THE SUBSTANCE OF THE INTERVIEW. (See MPEP Section 713.04). If a reply to the last Office action has already been filed, APPLICANT IS GIVEN A NON-EXTENDABLE PERIOD OF THE LONGER OF ONE MONTH OR THIRTY DAYS FROM THIS INTERVIEW DATE, OR THE MAILING DATE OF THIS INTERVIEW SUMMARY FORM, WHICHEVER IS LATER, TO FILE A STATEMENT OF THE SUBSTANCE OF THE INTERVIEW. See Summary of Record of Interview requirements on reverse side or on attached sheet.

Examiner Note: You must sign this form unless it is an Attachment to a signed Office action.

Examiner's signature, if required

DOCKET No.
HIT1P022/HSJ9-2003-0129US1

U.S. PATENT APPLICATION
FOR
WRITE POLE FABRICATION FOR
PERPENDICULAR RECORDING

INVENTOR(S):

Quang Le

Hin Pong E. Lee

~~Jiu-Lung Li~~ - Jui-Lung Li -

Aron Pentek

Nian-Xiang Sun

TN

ASSIGNEE: HITACHI GLOBAL STORAGE TECHNOLOGIES

SILICON VALLEY IP GROUP, PC
P.O. Box 721120
SAN JOSE, CA 95172